

Substitute for form 1449A-PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use as many sheets as necessary)</i>	Complete if known	
	Application Number	10/572,525
	Filing Date	March 20, 2006
	First Named Inventor	Kang, Xuejun
	Group Art Unit	2811 2823
	Examiner Name	Unknown Khiem D. Nguyen
Sheet 1 of 1	Attorney Docket No: 7989P002	

US PATENT DOCUMENTS					
Examiner Initial *	Cite No. ¹	USP Document Number	Publication or Issue Date MM-DD-YYYY	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear

FOREIGN PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Foreign Patent Document Country Code/Number/Kind Code (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear T ²

OTHER DOCUMENTS -- NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		CHU, CHEN F., et al., "Comparison of p-Side Down and p-Side Up GaN Light-Emitting Diodes Fabricated by Laser Lift-Off", <u>Japan Journal of Applied Physics</u> , Vol. 42, (02/15/2003), 147-150	
		LI, W H., et al., "Electrochemical deposition of Copper on patterned Cu/Ta(N)SiO2 surfaces for super filling of sub-micron features", <u>Journal of Applied Electrochemistry</u> , Vol. 31, (2001), 1395-1397	

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /KN/

EXAMINER

/Khiem Nguyen/

DATE CONSIDERED

04/27/2009